

In re application of: Jong-won LEE et al.

Serial No.: 09/899,627

Group: Art Unit 2822

Filed: July 5, 2001

Examiner: Guerrero, Maria E.

For:

**SOLUTION FOR CHEMICAL MECHANICAL POLISHING AND METHOD OF MANUFACTURING COPPER METAL INTERCONNECTION LAYER USING THE SAME**

Mail Stop AF

Commissioner for Patents

PO Box 1450

Alexandria VA 22313-1450

**AMENDMENT TRANSMITTAL FORM**

Sir:

Transmitted herewith is an amendment in the above-identified application.

- ☐ Small entity status of this application under 37 C.F.R. § 1.9 and 1.27 has been established by a verified statement previously submitted.
- ☐ A verified statement to establish small entity under 37 C.F.R. § 1.9 and 1.27 is enclosed.
- ☒ No additional fee is required.

The fee has been calculated as shown below:

	(Col. 1)		(Col. 2)		(Col. 3)	SMALL ENTITY	OTHER THAN SMALL ENTITY			
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR		PRESENT EXTRA	RATE	ADDIT. FEE	OR	RATE	ADDIT. FEE
TOTAL	15 *	MINUS	20**	= 0	X	25	\$ 0	X	50	\$ 0
INDEP.	2 *	MINUS	3***	= 0	X	100	\$ 0	X	200	\$ 0
<input type="checkbox"/> FIRST PRESENTATION OF MULTIPLE DEP. CLAIM						X	180	\$	X	360
						TOTAL	ADDIT. FEE		OR TOTAL	\$ 0

\* If the entry in Co. 1 is less than entry in Col. 2, write "0" in Col. 3.

\*\* If the "Highest No. Previously Paid For" IN THIS SPACE is less than 20, enter "20".

\*\*\* If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, enter "3".

The Highest No. Previously Paid For" (Total or indep.) is the highest number found in the appropriate box in Col. 1 of a prior amendment or the number of claims originally filed.

- ☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$\_\_\_\_. Two (2) copies of this sheet are enclosed.
- ☐ Please charge fee of \$\_\_\_\_ for \_\_\_\_\_ by Credit Card Payment Form PTO-2038 enclosed herewith
- ☒ Please charge any deficiency as well as any other fee(s) which may become due under 37 C.F.R. § 1.16 and/or 1.17 at any time during the pendency of this application, or credit any overpayment of such fee(s) to Deposit Account No. **50-0679**. Also, in the event any extensions of time for responding are required for the pending application(s), please treat this paper as a petition to extend the time as required and charge Deposit Account No. **50-0679** therefor. **TWO (2) COPIES OF THIS SHEET ARE ENCLOSED.**

Respectfully submitted,

F. CHAU & ASSOCIATES, LLC  
130 Woodbury Road  
Woodbury, New York 11797  
Tel: (516) 692-8888  
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*David L. Heath*  
David L. Heath  
Reg. No. 43,763  
Attorney for Applicant

**CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Mail Stop AF, Commissioner for Patents, PO Box 1450, Alexandria VA 22313-1450 on **September 19, 2005.**

Dated: 9/19/05

*David L. Heath*  
David L. Heath





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**BOX AF**

**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCESSING  
EXAMINING GROUP ART UNIT 2621**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Jong-won Lee et al.

Docket: 8021-55 (SS-14743-US)

Serial No.: 09/899,627

Group Art Unit: 2822

Filed: July 5, 2001

Examiner: Guerrero, Maria F.

For: **SOLUTION FOR CHEMICAL MECHANICAL POLISHING AND  
METHOD OF MANUFACTURING COPPER METAL  
INTERCONNECTION LAYER USING THE SAME**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE UNDER 37 C.F.R. § 1.116**

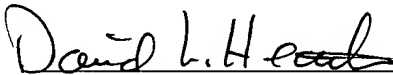
In reply to the Final Office Action dated June 22, 2005, please reconsider the above-identified application in light of the following amendments and remarks.

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I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Mail Stop AF, Commissioner for Patents, PO Box 1450, Alexandria VA 22313-1450 on **September 19, 2005**.

Dated: 9/19/05

  
David L. Heath